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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on December 2, 2005.

*Er Witt*  
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Attorney for Applicants

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.	:	10/782,533	Confirmation No.: 3242
Applicant	:	An Shih et al.	
Title	:	THIN FILM TRANSISTOR HAVING LDD REGION AND PROCESS FOR PRODUCING SAME	
Filed	:	February 19, 2004	
TC/A.U.	:	2826	
Examiner	:	Scott R. Wilson	
Docket No.	:	3304.2.120	
Customer No.	:	21552	

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Dear Sir:

This paper is filed in response to the Office Action of September 12, 2005.

**Remarks/Arguments** begin on page 2 of this paper.